

3-21-02  
JP  
Docket: 740819-725

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of )  
Yasutoshi OKUNO et al. )  
Japanese Priority Application No. 2001-030068 ) Attn: Application  
Japanese Priority Date: February 6, 2001 ) Branch  
For: METHOD FOR FABRICATING )  
SEMICONDUCTOR DEVICE ) Date: January 2, 2002



INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents and Trademarks  
Washington, D.C. 20231

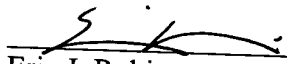
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

At least some of the references listed on PTO Form-1449 are discussed in the specification of the present application.

Copies of these references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,

  
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